

2015 International Workshop on EUV Lithography

Makena Beach & Golf Resort, Maui, Hawaii, USA

June 15-19, 2015

Workshop Agenda Outline

Monday, June 15, 2015

8:30 AM -5:00 PM

EUV Lithography Short Course (Makena Salon)

Tuesday, June 16, 2015

3:00 PM - 5:00 PM

Registration (Kaeo Ballroom Foyer)

Speaker Prep (Wailea Salon)

6:00 PM - 7:30 PM

Reception (Pacific Lawn)

Wednesday, June 17, 2015

7:30 AM – 8:30 AM Breakfast (Café Kiowai)

8:30 AM – 11:40 AM Oral Presentations (Wailea Salon)

11:40 AM – 1:00 PM Lunch (Molokini Room)

1:00 PM – 4:00 PM Oral Presentations (Wailea Salon)

4:00 PM Afternoon off for Networking

Thursday, June 18, 2015

7:30 AM – 8:30 AM Breakfast (Café Kiowai)

8:30 AM – 12:00 PM Oral Presentations (Wailea Salon)

12:00 PM – 1:00 PM Lunch (Molokini Room)

1:00 PM – 5:00 PM Oral Presentations (Wailea Salon)

5:00 PM - 6:00 PM Poster Session

6:30 PM – 8:00 PM Dinner (Pacific Lawn)

Friday, June 19, 2015

8:30 AM – 10:00 AM EUVL Workshop Steering Committee Meeting (Café Kiowai)